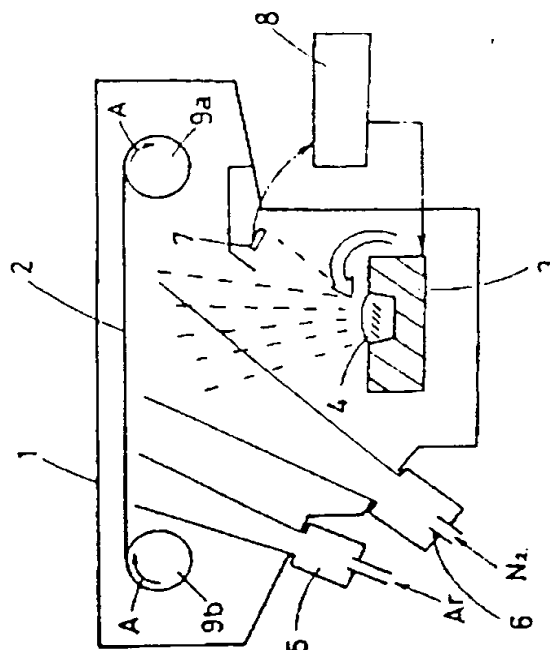


Patent Abstracts of Japan

TITLE : METHOD AND DEVICE FOR FORMING
THIN FILM



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